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PELLICLE FILM THINNING TEST

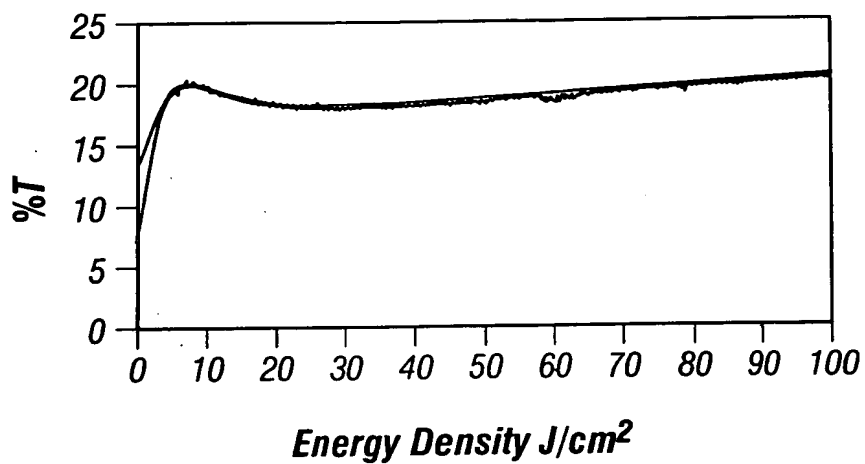


FIG. 1

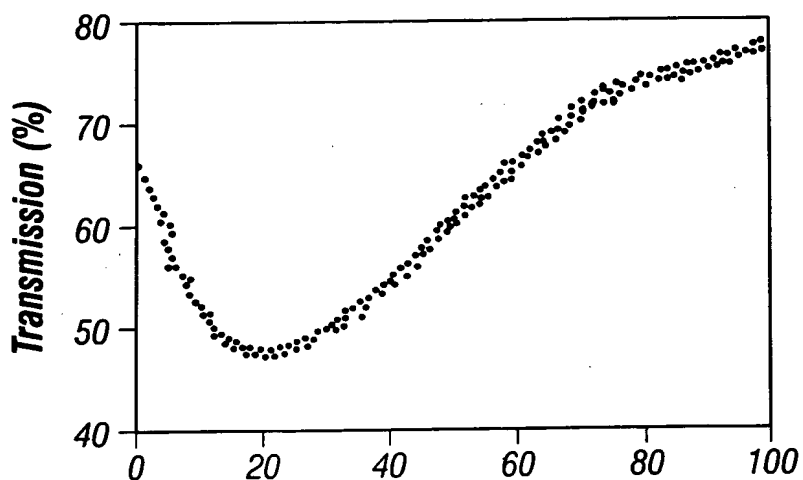


FIG. 2

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 PELLICLES AND RESIST FOR LITHOGRAPHY
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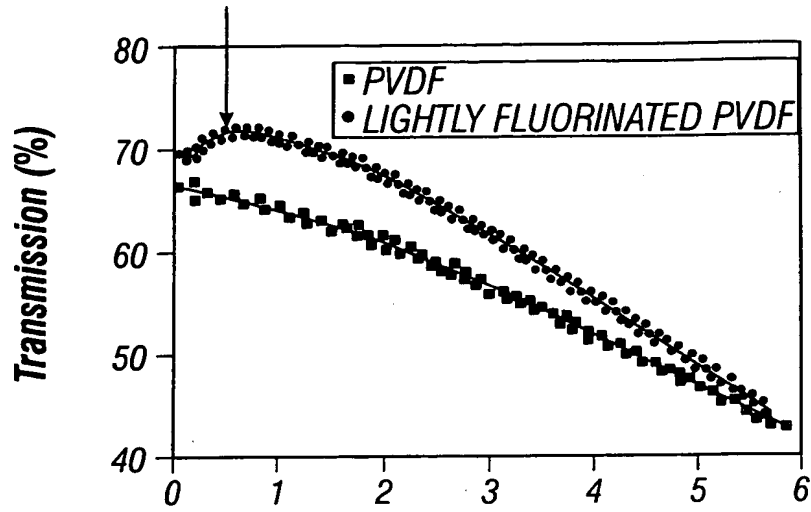


FIG. 3

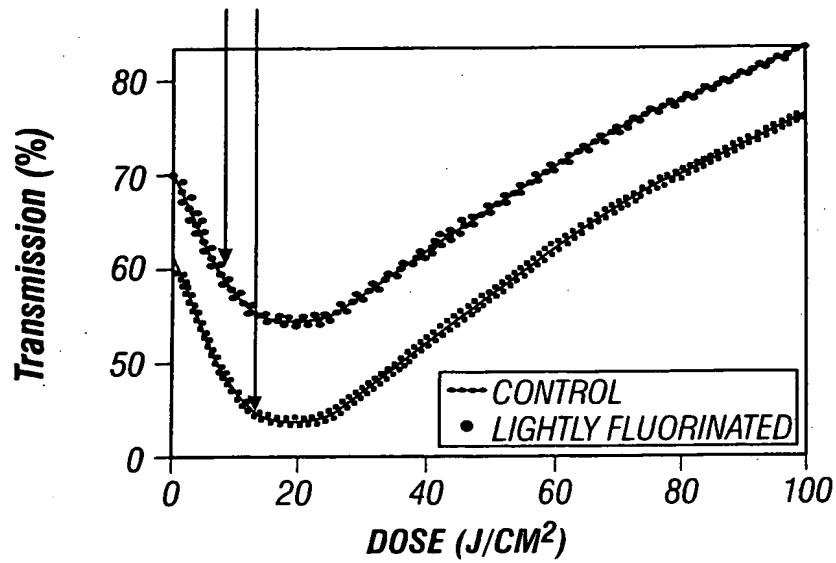


FIG. 4

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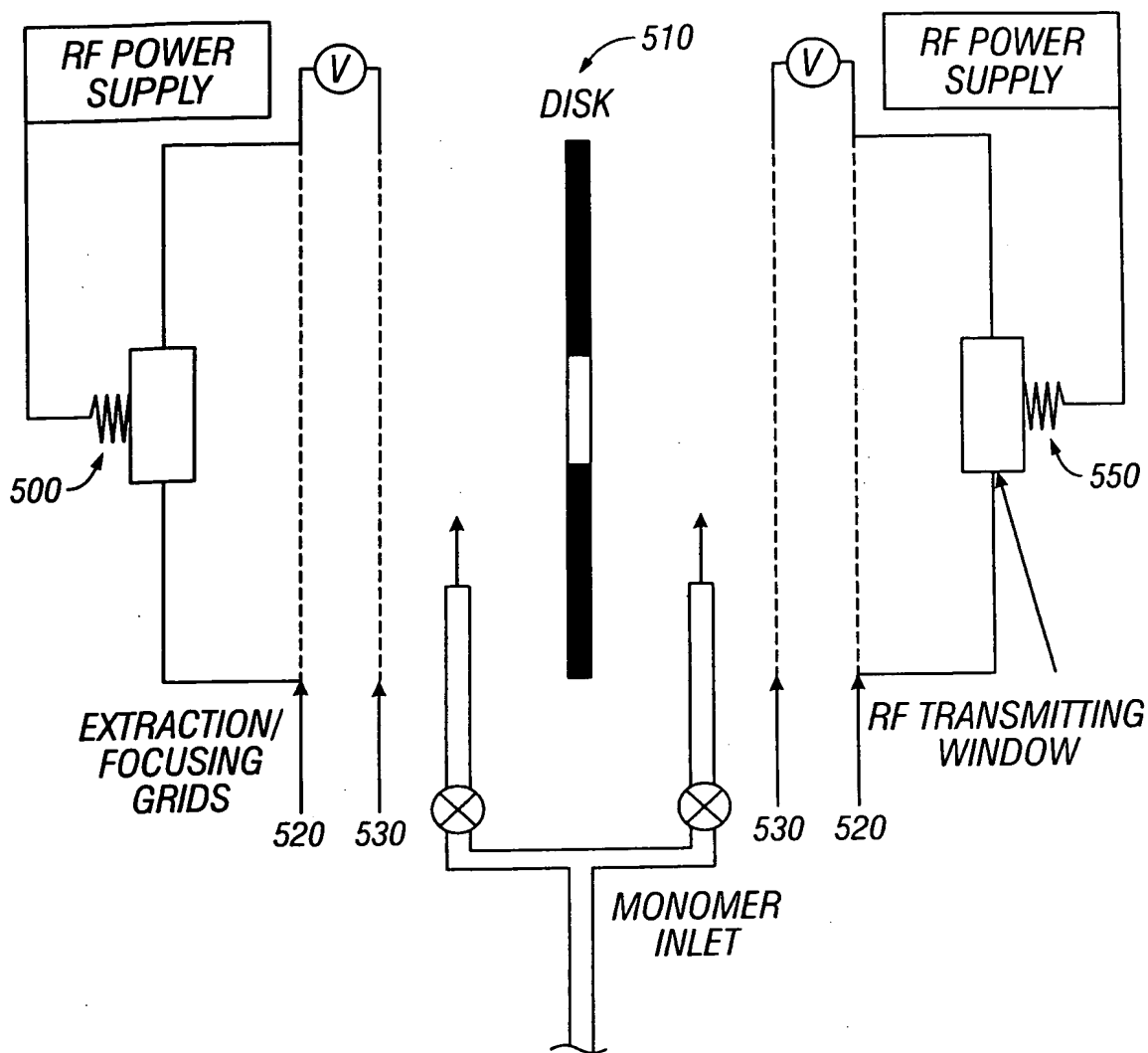


FIG. 5

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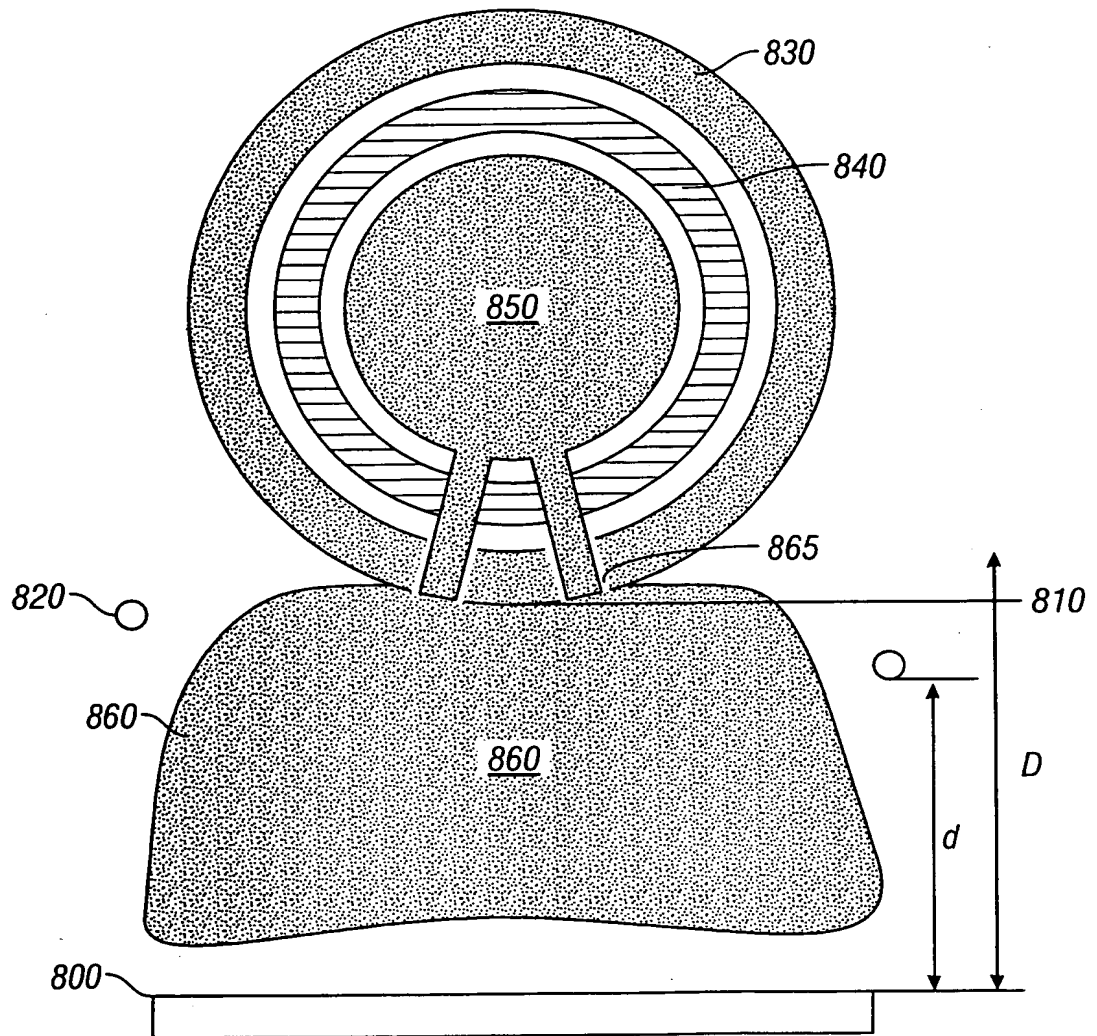


FIG. 7

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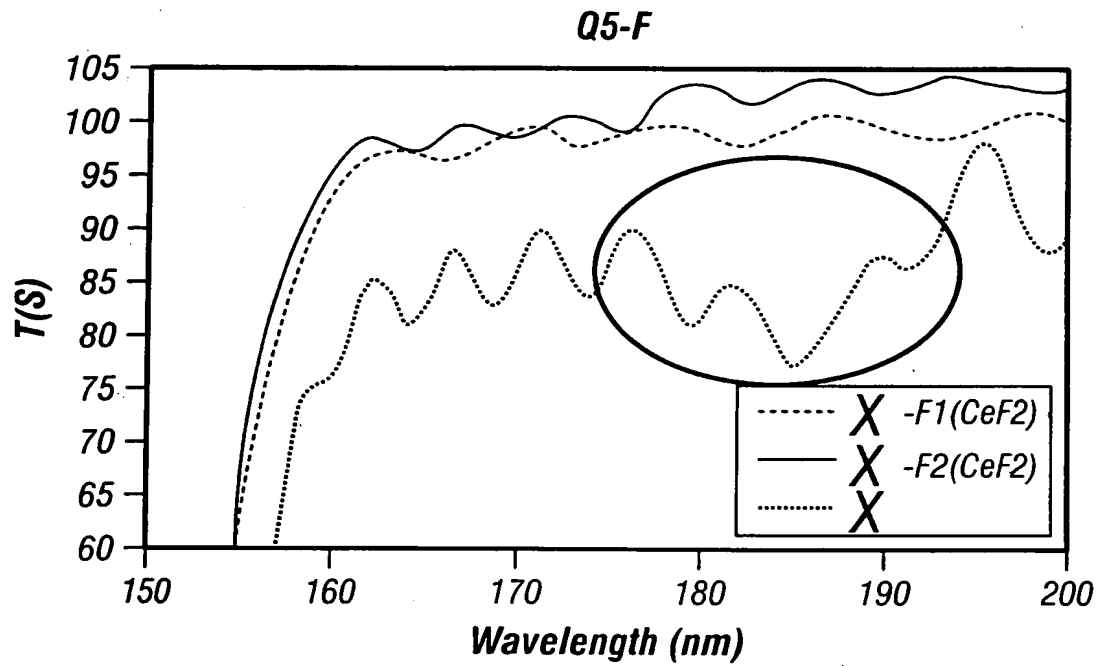


FIG. 8

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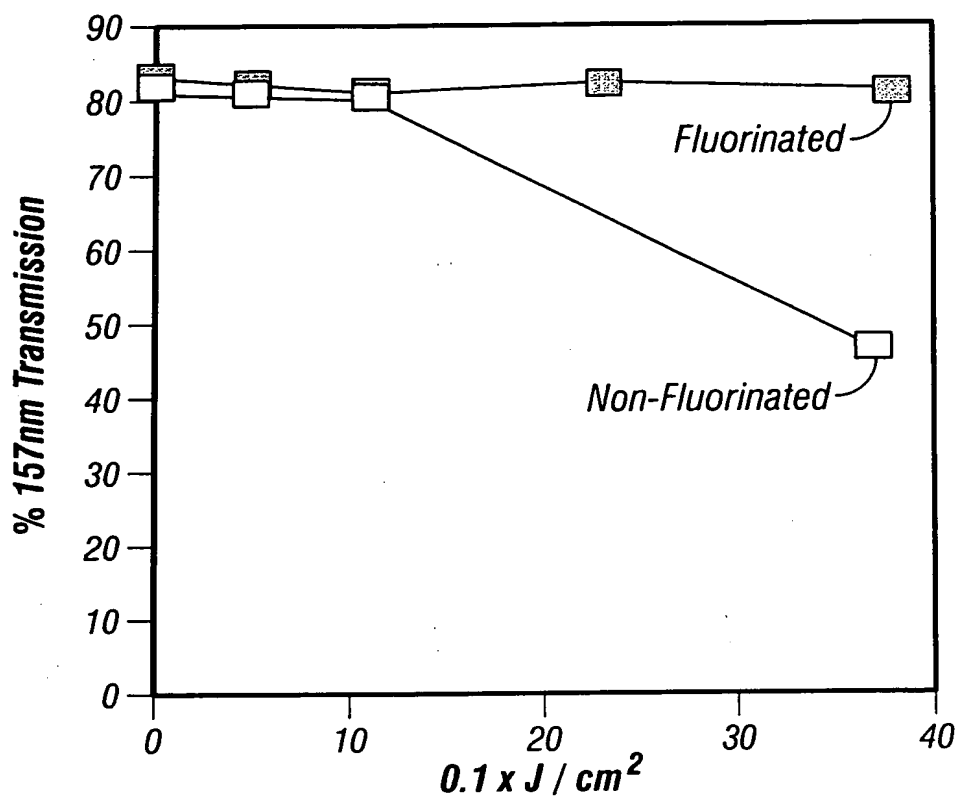
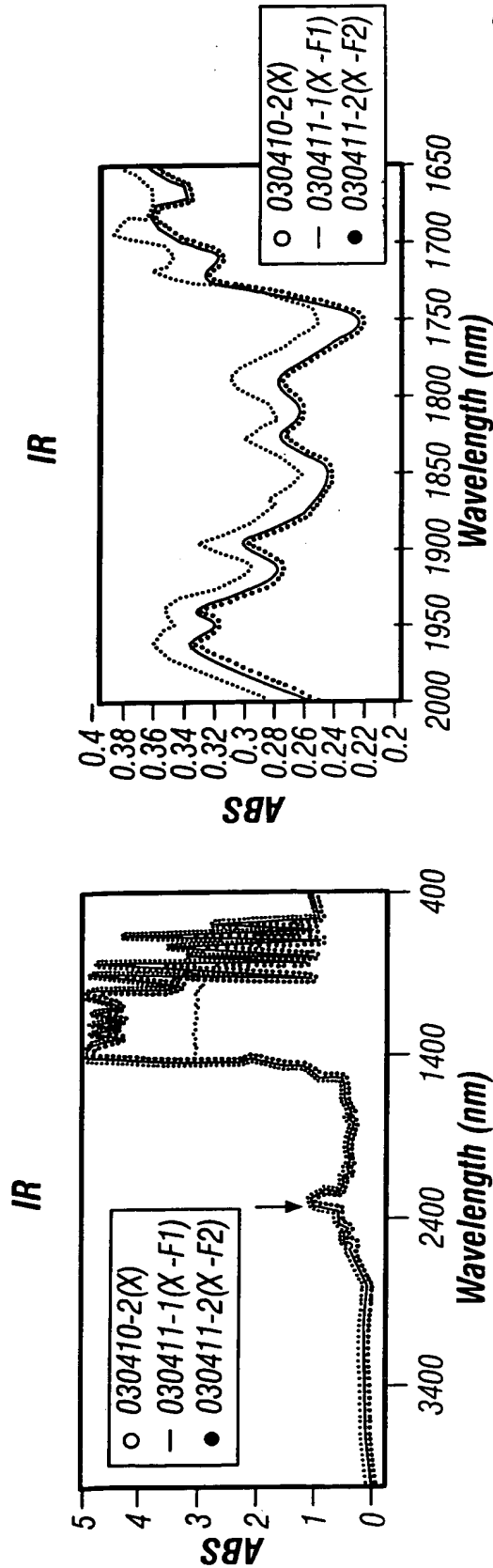


FIG. 9

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Peak Intensity Ratio (1790cm-1 vs 2290cm-1)

| | | | |
|----------------------|-------|-------|-------|
| | X | X-F1 | F-F2 |
| Peak Intensity Ratio | 0.488 | 0.414 | 0.409 |

FIG. 8